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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Mail Stop: ISSUE FEE**  
Akihisa HONGO et al. : **Confirmation No. 6855**  
Serial No. 10/017,384 : **Group Art Unit 1742**  
Filed December 18, 2001 : **Examiner Donald R. Valentine**

SUBSTRATE PLATING METHOD AND  
APPARATUS

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**AMENDMENT UNDER 37 CFR 1.312**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to the allowance for the above-referenced U.S. patent application, kindly amend  
the application as follows:

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975